DE1642 USSN: 10/539,883

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN THE MATTER OF:

ART UNIT: 1792

Jaehwan EUN, et al

EXAMINER: Kunemund, Robert M.

SERIAL NO.: 10/539,883

CONFIRMATION NO.: 1957

FILED: June 17, 2005

FOR: Method For Preparation of Ferroelectric Single Crystal Film Structure Using

Deposition Method

<u>AMENDMENT</u>

Commissioner for Patents P.O. Box 1450 Arlington, VA 22313-1450

SIR:

This is in response to the outstanding Office Communication dated November 14, 2007. The Commissioner is authorized to charge any fees required in the prosecution of this application to Deposit Account No. 503814.

Please amend the present application as follows: